

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hsien-Hua Tseng

Group Art Unit: 3652

Serial No.: 10/072,704

Examiner: Dean J. Kramer

Filed:

Feb. 7, 2002

In Response to Office Action

Dated:

July 18, 2003

For:

Wafer Transport Pod with Linear Door Opening Mechanism

Attorney Docket No.: 67,200-674

RECEIVED

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GROUP 3600

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I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: October 20, 2003

RESPONSE TO OFFICE ACTION

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action mailed July 18, 2003, please enter the following amendments and consider the following remarks.